

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

David C. Brown, et al..

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EXAMINER:

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FILED:

February 13, 2002

FOR:

FREE SPACE OPTICAL SWITCH

Assistant Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMEN

In compliance with 37 C.F.R. §§1.56, 1.97, and 1.98, Applicant submits copies of the documents listed on the attached Form PTO-1449.

Applicant believes that no fee is required in connection with this submission, however, the Commissioner is authorized to charge Deposit Order Account No. 19-0079 for any fee that is required.

Respectfully submitted,

William E. Hilton

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CERTIFICATE OF EXPRESS MAIL UNDER 37 C.F.R. §1.10

I hereby certify that this Information Disclosure Statement and the documents referred to as enclosed therein are being deposited with the United States Postal Service on June 5, 2003 in an envelope as "Express Mail Post Office to Addressee" Mailing Label Number EL754088945US addressed to the: Assistant Commissioner of Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Dana Casterlir

KREV. 592)

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OF AMERICAN DISCLOSURE STATEMENT BY APPLICANT

ATTORNEY DOCKET NO. 6689-B

APPLICANT: David C. Brown, et al.

GROUP: 2873

FILING DATE: February 13, 2002

EXAMINER: unknown

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